

**PATENT APPLICATION**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Ryo KUBOTO, et al.

Appln. No.: 09/817,233

Confirmation No.: 8072

Filed: March 27, 2001



Docket No: Q62494

Group Art Unit: 2823

Examiner: Hsien Ming LEE

For: **MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE HAVING DRAM CAPACITORS**

**STATEMENT UNDER 37 C.F.R. § 1.97(e)**

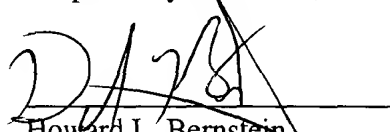
Commissioner for Patents  
Washington, D.C. 20231

Sir:

The undersigned hereby states, upon information and belief:

That each item of information contained in the Information Disclosure Statement filed concurrently herewith was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of said Information Disclosure Statement.

Respectfully submitted,

  
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